

**RESPONSE UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP 3742  
Docket No.: 0300.1185**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of:

Kazutaka KOBAYASHI

Serial No. 10/537,863

Group Art Unit: 3742

Confirmation No. 7195

Filed: June 6, 2005

Examiner: Maria Alexandra Elve

For: METHOD OF FORMING VIA HOLE IN RESIN LAYER

**AMENDMENT AFTER FINAL REJECTION**

**Mail Stop AF**  
Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

Sir:

This is in response to the final Office Action mailed September 18, 2008, which has a period for response set to expire on December 18, 2008.

Reconsideration of the claims is respectfully requested. The following remarks are respectfully submitted.